



AF
JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2825
Examiner: Naum B. Levin

In Re PATENT APPLICATION OF:

Applicant : An-Ru Andrew CHENG et al.
Appln. No. : 10/626,634
Filed : July 25, 2003
For : INTEGRATED CIRCUIT CAPABLE OF
LOCATING FAILURE PROCESS
LAYERS
Attorney Ref. : TOP 298

**AMENDMENT
AFTER FINAL**

November 23, 2005

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Amendment is timely filed in response to the Examiner's Action mailed September 21, 2005. Please amend the above-referenced application as shown in the **Amendments to the Claims** beginning on page 2, and withdraw the final rejection.

FEE ENCLOSED: \$
Please check any further
fee to our Deposit Account
No. 18-0002